

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Masaru Yamaguchi
Appl. No.: Unknown
Conf. No.: Unknown
Filed: May 6, 2004
Title: DEPOSITION MASK, METHOD FOR MANUFACTURING DISPLAY UNIT
USING IT, AND DISPLAY UNIT
Art Unit: Unknown
Examiner: Unknown
Docket No.: 112857-479

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Sir:

In accordance with the provisions of 37 C.F.R. 1.56, 37 C.F.R. 1.97, and 37 C.F.R. 1.98, Applicants request that a citation and examination of the references cited below, and on the attached PTO-1449 form, copies of which are enclosed, be made during the course of examination of the above-identified application for United States patent.

FOREIGN PATENT DOCUMENTS

<u>Document No.</u>	<u>Date</u>	<u>Country</u>
2001-195008	September 17, 2001	Japan

Applicants look forward to early and favorable consideration of this matter.

Respectfully submitted,

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BY 

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Dated: May 6, 2004

INFORMATION DISCLOSURE CITATION IN AN APPLICATION (Use several sheets if necessary)	Atty Docket No.	Application No.
	112857-479	Unknown
	Applicant	Masaru Yamaguchi
	Filing Date	Group
May 6, 2004	Unknown	

Examiner's Initials	OTHER DOCUMENTS (<i>Including Author, Title, Date, Pertinent Pages, Etc.</i>)

Examiner:	Date Considered:
<p>*Examiner: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.</p>	